



2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Xiaoju Wu

Serial No.: 09/997,972

Filed: 11/29/2001

For: METHOD FOR MANUFACTURING AND STRUCTURE OF SEMICONDUCTOR DEVICE WITH POLYSILICON DEFINITION STRUCTURE

Docket No.: TI-33005

Examiner: Lattin, C.

Art Unit: 2812

#3
Section
J. Minnillor
6/12/03ELECTION

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

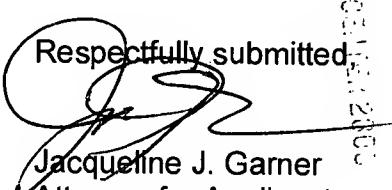
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I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as first Class Mail in an envelope addressed to Assistant Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.

6-5-03
Date
Marianna Smith
Marianna Smith

Dear Sir:

With respect to the Restriction Requirement mailed on 5/15/2003, the Examiner has restricted the instant application to the invention of Group I (Claims 1-11) or Group II (Claims 12-21). In light of this, Applicant elects to pursue Group I, (Claims 1-11) without traverse.

Respectfully submitted,


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